



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/800,450
Applicant : Emmanuel Hadji, et al.
Filed : March 15, 2004
Title : METHOD FOR FORMING AN OPTICAL SILICON LAYER ON A SUPPORT AND USE OF SAID METHOD IN THE PRODUCTION OF OPTICAL COMPONENTS

Confirm No. : 1230
TC/A.U. : 2825
Examiner : Chuong A. Luu

Docket No. : 33019US1

REQUEST FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir/Madam:

The three month period for response to the Office action of October 26, 2005 in the above-identified application expired on January 26, 2006. Accordingly, applicants respectfully request and petition that the response date be extended for three additional months, up to and including April 26, 2006. The additional \$2160.00 extension of time fee is enclosed.

If there are any further fees required by this communication which are not covered by an enclosed check, please charge such fees to our Deposit Account No. 16-0820, Order No. 33019US1.

Respectfully submitted,

PEARNE & GORDON LLP

By:



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Date: May 30, 2006